

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

U.S. Patent No.: 7,498,124
Issue Date: March 3, 2009
Serial No.: 10/675,419
Applicant: John M. Kulp
Title: **SACRIFICIAL SURFACTANATED PRE-WET FOR DEFECT REDUCTION IN A SEMICONDUCTOR PHOTOLITHOGRAPHY DEVELOPING PROCESS**
Attorney Docket: CT-001
Confirmation No.: 6182

Cincinnati, Ohio 45202

November 30, 2009

VIA ELECTRONIC FILING

Certificate of Corrections Branch
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR CERTIFICATE OF CORRECTION

(37 CFR §§ 1.322(a), 1.323)

It is respectfully requested that a Certificate of Correction be issued for the above-identified patent. The patent contains errors that occurred through the fault of the U.S. Patent and Trademark Office. The patent also contains errors that occurred by Applicant in the specification.

Form PTO/SB/44 outlining the corrections to be made is submitted herewith.

Applicants believe a fee of \$100 is due as a result of this request. If any deficiencies or credits are necessary to complete this communication, please apply them to Deposit Account No. 23-3000.

Respectfully submitted,

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CERTIFICATE OF CORRECTIONPage 1 of 1

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APPLICATION NO.: 10/675,419

ISSUE DATE : March 3, 2009

INVENTOR(S) : John M. Kulp

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Cover Page, Col. 2, (57) ABSTRACT, "A method and apparatus for" should read --A method for--.

Col. 1, lines 36-37, "spin-drying in this case," should read --spin-drying. In this case,--.

Col. 9, line 14, "i.e., subjected a surfactant-containing" should read --i.e., subjected to a surfactant-containing--.

Col. 13, line 7, Claim 1, "applying the resist film surfactant-containing" should read --applying the sacrificial surfactant-containing--.

Col. 13, line 8, Claim 1, "the substrate to displace" should read --the resist film to displace--.

MAILING ADDRESS OF SENDER (Please do not use customer number below):

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This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.